

**Electronic Patent Application Fee Transmittal****Application Number:**

10813390

**Filing Date:**

31-Mar-2004

**Title of Invention:**

System and method of removing chamber residues from a plasma processing system in a dry cleaning process

**First Named Inventor/Applicant Name:**

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**Filer:**

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**Attorney Docket Number:**

250312US6 YA

Filed as Large Entity

**Utility under 35 USC 111(a) Filing Fees****Description****Fee Code****Quantity****Amount****Sub-Total in  
USD(\$)****Basic Filing:****Pages:****Claims:****Miscellaneous-Filing:****Petition:****Patent-Appeals-and-Interference:**

Filing a brief in support of an appeal

1402

1

510

510

**Post-Allowance-and-Post-Issuance:****Extension-of-Time:**

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension - 2 months with \$0 paid	1252	1	460	460
<b>Miscellaneous:</b>				
<b>Total in USD (\$)</b>				<b>970</b>